

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q63607

Ichirou MIYAGAWA

Appln. No.: 09/828,163

Group Art Unit: 2861

Confirmation No.: 6555

Examiner: Hai Chi PHAM

Filed: April 9, 2001

For: EXPOSURE RECORDING APPARATUS AND METHOD OF ADJUSTING THE  
AMOUNT OF LIGHT THEREIN

**RESPONSE UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 13, 2006, please consider the remarks  
as follows on the accompanying pages.

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